

## **Application Data Sheet**

<b>Application Information</b>	
Application Number::	not assigned
Filing Date::	not assigned
Application Type::	Regular
Subject Matter::	Utility
Suggested Classification::	
Suggested Group Art Unit::	
Title::	Method and Apparatus for Scanning a Semiconductor Wafer
Attorney Docket Number::	21295.73 (H5749US)
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	3
Total Drawing Sheets::	3
Small Entity?::	No
Licensed US Govt. Agency::	
Contract or Grant Numbers::	
Secrecy Order in Parent Appl.?::	

<b>Applicant Information</b>	
Applicant Authority Type::	Inventor
Primary Citizenship Country::	Germany
Status::	Full Capacity
Given Name::	Detlef
Middle Name::	
Family Name::	Michelsson
Name Suffix::	
City of Residence::	Wetzlar-Naunheim
State or Province of Residence::	
Country of Residence::	Germany
Street of mailing address::	Sonnenstrasse 20
City of mailing address::	Wetzlar-Naunheim
State or Province of mailing address::	
Country of mailing address::	Germany
Postal or Zip Code of mailing address::	D-35584
<b>Correspondence Information</b>	
Correspondence Customer Number::	029127

Representative Information	
Representative Customer Number::	029127

Foreign Priority Information			
Country::	Application number::	Filing Date::	Priority Claimed::
Germany	DE10307358.2-52	02/21/2003	Yes

Assignee Information	
Assignee Name::	Houston Eliseeva LLP
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